

Title (en)

APPARATUS AND METHOD FOR SURFACE PROCESSING

Title (de)

VORRICHTUNG UND VERFAHREN ZUR OBERFLÄCHENBEARBEITUNG

Title (fr)

APPAREIL ET PROCÉDÉ POUR LE TRAITEMENT DE SURFACE

Publication

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Application

EP 10778640 A 20101111

Priority

EP 2010067301 W 20101111

Abstract (en)

[origin: WO2012062369A1] An apparatus for coating parts, comprising a deposition chamber (1) and a plurality of coating equipments (2, 3) for simultaneously or successively providing coating materials to said deposition chamber, wherein at least one of said coating equipment (2) is a metal filtered arc ion source, wherein at least one other of said coating equipment (3) is a laser ablation source, At least two of said coating equipments are removably connected to said deposition chamber via connecting flanges (10). At least two of said flanges are identical, so that one said coating equipment (2, 3) can be connected via different flanges to said deposition chamber.

IPC 8 full level

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CPC (source: EP)

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See references of WO 2012062369A1

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